



LIGO-D970425-01-V

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DWG. NO.	DESCRIPTION	DWG. NO.	DESCRIPTION

ISSUE NO.	ISSUE DESCRIPTION	REV.	DESCRIPTION	CHKD.	DRWN.	DATE	DEDR.
0	ISSUED FOR FABRICATION						
0	REISSUED FOR FABRICATION PER RFC V049-053					04/05/97	0456

PROCESS SYSTEMS INTERNATIONAL, INC.
20 WALKUP DR. WESTBOROUGH, MASSACHUSETTS 01581 USA

HAM - 75L/S ION PUMP SUPPORT
LIGO VACUUM EQUIPMENT

CAD FILE	V0494123	SIZE	D	DWG. NO.	V049-4-123	REV.	1
SCALE	AS NOTED	SHEET					1 OF 1

UNLESS OTHERWISE SPECIFIED
DIMENSIONS ARE IN INCHES
TOLERANCES:
FRACTIONAL ± .01
ANGULAR ± .01° BOND ± .2°
TWO PLACE DECIMAL ± .02
THREE PLACE DECIMAL ± .005
FINISHED SURFACE FIN. OUT.
BREAK CORNERS TO REMOVE ALL BURRS